

DOCKET NO.: 273959US26X PCT/anw

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Toru KIMURA, et al.

SERIAL NUMBER: 10/539,571

GROUP: 3781

FILED: June 17, 2005

EXAMINER: HYLTON, ROBIN  
ANNETTE

FOR: VACUUM CONTAINER APPARATUS USED FOR MANUFACTURING  
SEMICONDUCTOR DEVICES AND LID APPARATUS FOR SAME.

**REQUEST TO CORRECT TITLE OF INVENTION**

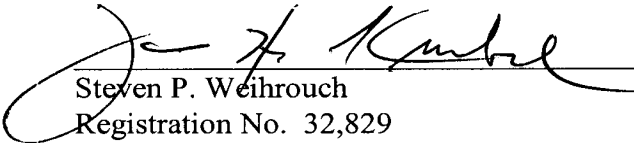
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SIR:

In the matter of the above-identified application for patent, we hereby request correction of your records to reflect the correct title of the invention. The title of the invention should read as follows: VACUUM CONTAINER APPARATUS USED FOR MANUFACTURING SEMICONDUCTOR DEVICES AND LID APPARATUS FOR SAME..

Respectfully Submitted,

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